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PATENT APPLICATION
ATTORNEY DOCKET NO. LMRX-P037/P1258

IN THE
UNITED STATES PATENT & TRADEMARK OFFICE

Applicant: AVOYAN et al.

Application No. 10/813,829

Examiner: KACKAR, R.N.

Filed: 03/30/2004

Group No. 1763

Title: A METHOD OF PLASMA ETCH
ENDPOINT DETECTION USING A V-I
PROBE DIAGNOSTICS

Confirmation No. 5065

CERTIFICATE OF ELECTRONIC FILING

I hereby certify that this document and its attachments are being filed
with the U.S. P.T.O. via EFS filing on May 2, 2007.

Signed: /Sandra Halliwell/
Sandra Halliwell

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §§ 1.56 AND 1.97(c)

Dear Examiner:

The references listed in the attached PTO Form 1449 may be material to the patentability of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§ 1.56 and 1.97. The Examiner is requested to make these references of official record in this application. The information contained herein was first cited in a communication from a foreign patent office in a counterpart foreign application and mailed 16 JAN 2007.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

Applicant has made arrangements on the EFS website to pay the \$180 fee for filing this Information Disclosure Statement via credit card. The Commissioner is hereby authorized to charge any additional fees required to process this Information Disclosure Statement to our Deposit Account 50-2284 (Order No. LMRX-P037).

Respectfully submitted,
/Joseph A. Nguyen/ Reg. 37,899
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